

## Progress on the "Slim Edges" Project

*Tuesday 22 November 2011 11:30 (20 minutes)*

The UCSC-NRL "Slim Edges" Project made good progress.

The laser scribing+cleaving was replaced by XeF<sub>2</sub> etching+cleaving leading to a much improved i-V curve.

The edge passivation has also been finalized with Alumina for p-type sensors and Nitrogen PECVD for n-type.

Charge collection will be discussed in a second talk

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